

Solutions for Research,
Development & Production

UHV Technology



HIGH VACUUM & **ULTRA HIGH VACUUM SYSTEMS**

We design and manufacture a wide range of bespoke HV and UHV systems configured with any combination of techniques such as:

- XPS / ESCA
- IRAS
 - MOKE
 - Thermal evaporation

AFM

• STM

• TPD

· LEED / AES

- UPS • MBE

 - PLD
- ARPES ARUPS

• HREELS

• HP XPS

- - RHEED

 - CVD
- FTIR

· ISS

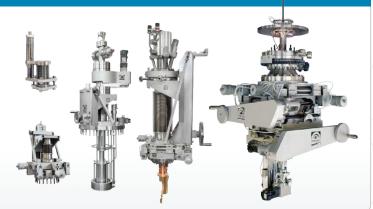
- PECVD
- HIPIMS
- RIXS
 - others



MANIPULATORS, GONIOMETERS & FEEDTHROUGHS

· Sputter deposition

- XY stages
- Z manipulators
- XYZ manipulators
- Multi axes manipulators (up to 6 axes)
- Manipulators with rotations
- · LN2 or LHe cooled manipulators
- Motorization for all modules
- · Linear feedthroughs
- · Rotary feedthroughs
- Differentially pumped rotary feedthroughs
- Linear shifts
- · Wobble sticks
- Goniometers



CHAMBERS AND MECHANISMS

- Analytical chambers
- Preparation chambers
- · Load lock chambers
- Sample park chambers
- Radial distribution chambers
- · High pressure reactors
- Cleaver chambers
- · Reorientation chambers
- Linear transfers
- Transport boxes





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SAMPLE HOLDERS

- Sample heating by resistive heating method (up to 1000°C), direct heating or electron beam heating (up to 2000°C)
- Various types of the PTS sample holders up to 8"
- · Helium and nitrogen cooling
- Versions for reactive gas atmospheres
- Holders dedicated for: quartz balance, Faraday cup, high pressure reactors, powder materials
- Adapters for flag style sample holders
- · Detachable contact for heating & cooling
- IR & UV transmission mode
- Integrated charge compensation

Approximately 200 individual designs of sample holders have been manufactured to date.



INSTRUMENTS

- Hemispherical energy analyzer
- X-ray source
- X-ray monochromator
- UV source
- · Ion source with wien filter option
- · Electron source
- Flood source
- Electron beam evaporator
- Effusion cell
- Cylindrical mirror analyzer
- Quartz balance
- Thermal desorption spectrometer



ACCESSORIES

• Titanium sublimation pumps and liquid nitrogen shields

Vacuum KF-fittings

- Ultra high vacuum CF-fittings
- · Electrical feedthroughs
- · Fluid feedthroughs
- · Bakeout equipment
- Components for load locks
- Vacuum doors
- Shutters
- Mass flow control systems
- Water cooling devices



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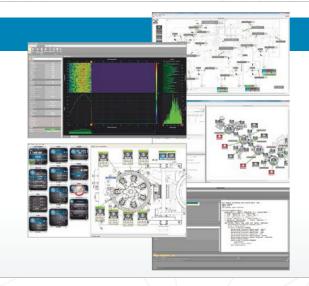
ELECTRONICS

- Vacuum control devices
- Thickness monitor controllers
- Stepping motor control drivers
- · Ion source power supplies
- Sample heating power supplies
- Wide range vacuum gauge controllers
- Thickness/rate controllers
- Electron source power supplies
- Electron beam evaporator power supplies
- Titanium sublimation pump power supplies
- High voltage electronics
- · Bakeout control devices
- · Emission regulators



SOFTWARE

- Manipulator control application
- Thermal desorption spectroscopy control application
- Pressure control application
- PID control application (thermal process control)
- Automatization of the samples transfer system
- Vacuum process control system
- Able to connect/communicate with most of our devices
- Dedicated software for customers' systems and devices
- Integration with TANGO and other control systems



SERVICES

- Warranty & after warranty service
- Maintenance & repair services of Manipulators and vacuum transfers
- Maintenance & repair services of HV and UHV systems
- UHV compatible machining and welding
- Electronic units maintenance & repair services
- X-ray anodes recovery
- Components maintenance
- & repair services





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